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HEWLETT-PACKARD COMPANY
Intellectual Property Administration
P.O. Box 272400
Fort Collins, Colorado 80527-2400

PATENT APPLICATION 2811
ATTORNEY DOCKET NO. 10013802 -1

JAN 22 2004
IN THE
UNITED STATES PATENT AND TRADEMARK OFFICE

Patent & Trademark Office
Inventor(s): Zhizhang Chen et al Confirmation No.: 1660
Application No.: 10/085866 Examiner: Shouxiang, Hu
Filing Date: Feb 27, 2002 Group Art Unit: 2811
Title: Emission Layer Formed By Rapid Thermal Formation Process

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

This Information Disclosure Statement is submitted:

- () under 37 CFR 1.97(b), or
(Within three months of filing national application; or date of entry of national application; or before mailing date of first office action on the merits; whichever occurs last)
- (X) under 37 CFR 1.97 (c) together with either a:
(X) Statement under 37 CFR 1.97(e), or
() a \$180.00 fee under 37 CFR 1.17(p), or
(After the CFR 1.97 (b) time period, but before final action or notice of allowance, whichever occurs first)
- () under 37 CFR 1.97 (d) together with a:
() Statement under 37 CFR 1.97(e)(1) or (2), and
() a \$180.00 fee set forth in 37 CFR 1.17(p).
(Filed after final action, a notice of allowance, on or before payment of the issue fee)

Please charge to Deposit Account 08-2025 the sum of \$0.00 . At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25.

(X) Applicant(s) submit herewith Form PTO 1449 - Information Disclosure Statement together with any required copies of patents, publications or other information of which applicant(s) are aware, which applicant(s) believe(s) may be material to the examination of this application and for which there may be a duty to disclose in accordance with 37 CFR 1.56.

() A concise explanation of the relevance of foreign language patents, foreign language publications and other foreign language information listed on PTO Form 1449, as presently understood by the individual(s) designated in 37 CFR 1.56 (c) most knowledgeable about the content is given on the attached sheet, or where a foreign language patent is cited in a search report or other action by a foreign patent office in a counterpart foreign application, an English language version of the search report or action which indicates the degree of relevance found by the foreign office is listed on form PTO 1449 and is enclosed herewith.

It is requested that the information disclosed herein be made of record in this application.

- (X) I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450. Date of Deposit: 1/20/2004
OR
() I hereby certify that this paper is being transmitted to the Patent and Trademark Office facsimile number _____ on _____. Number of pages: _____

Typed Name: Heather A. Ellis

Signature: Heather A. Ellis

Respectfully submitted,

Zhizhang Chen et al

By Matthew L. Wad

Matthew L Wad

Attorney/Agent for Applicant(s)
Reg. No. 42,206

Date: 1/17/04

Telephone No.: 208 396 5263

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STATEMENT UNDER 37 CFR 1.97(e)

Sir:

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The undersigned hereby certifies that either:

- (X) Each item of information contained in the Information Disclosure Statement was cited for the first time in a communication from a foreign patent office in a counterpart foreign application, not more than three months prior to the filing of the statement, or
- () No item of information contained in the Information Disclosure Statement
- was cited in a communication from a foreign patent office in a counterpart foreign application, and
- to the knowledge of the undersigned, after making reasonable inquiry, was known to any individual designated in 37 CFR 1.56 (c) more than three months prior to the filing of the Information Disclosure Statement.

Respectfully submitted,
Zhizhang Chen et al

By Matthew L. Wade
Matthew L Wade

Attorney/Agent for Applicant(s)
Reg. No. 42,206

Date: 1/28/04
Telephone No.: 208 396 5263

PATENT APPLICATION

Sheet 1 of 2

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FORM PTO-1449

LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION DISCLOSURE
STATEMENT

(Use several sheets if necessary)

ATTY. DOCKET NO. 10013802-1	APPLICATION NO. 10/085,866	CONFIRMATION NO. 1660
APPLICANT Chen et al		
FILING DATE Feb 27, 2002	GROUP 2811	

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION DATE	NAME	Pages, Columns, Lines Where Relevant Passages or Figures Appear
1A	2003/0141494	Jul 31, 2003	Govyadinov et al	
1B				
1C				
1D				
1E				
1F				
1G				
1H				
1I				
1J				
1K				

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FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	Pages/Columns/Lines Where Relevant Passages/Figures Appear	Check if Translation attached
1L	EP0913849	May 06, 1999	Matsushita Electric		
1M	EP1094484	Apr 25, 2001	Matsushita Electric		
1N	EP1003195	May 24, 2000	Matsushita Electric		
1O	EP1267380	Dec 18, 2002	Hewlett-Packard Co		
1P	WO02/089168	Nov 07, 2002	Hewlett-Packard Co		

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

1Q	
1R	
1S	

EXAMINER

DATE CONSIDERED



PATENT APPLICATION

Sheet 2 of 2

FORM PTO-1449

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2A				
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	2L	WO02/35572	May 02, 2002	Matsushita Electric		
	2M	WO02/089166	Nov 07, 2002	Matsushita Electric		
	2N	WO02/103738	Dec 27, 2002	Hewlett-Packard Co		
	2O	WO02/089167	Nov 07, 2002	Hewlett-Packard Co		
	2P					

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

2Q	
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2S	

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